

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Nobuo NAITO et al.

Application No.: New U.S. National Stage of PCT/JP2005/000644

Filed: May 23, 2006

Docket No.: 128132

For: ELECTROMAGNETIC WAVE SHIELDING FILM AND METHOD FOR PRODUCING  
THE SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450.  
Alexandria, VA 22313-1450

Sir:

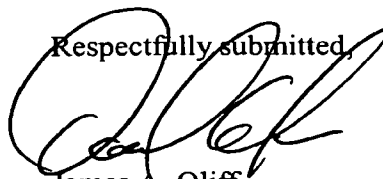
Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of one or more non-English language reference is discussed in the present specification. See References 9-11.
- ☒ 3. One or more reference cited herein was cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information. See References 1-8.
- ☒ 4. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- ☒ 5. An English language Abstract of one or more non-English language reference is attached hereto. See References 4-11.
- ☒ 6. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See References 4-11.

LAPG Rec'd PCT/PTO 23 MAY 2006

- ☒ 7. Reference 4 corresponds to reference 1. References 5-6 correspond to reference 2. Reference 8 corresponds to reference 3.

Respectfully submitted,



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Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 128132		APPLICATION NO. New U.S. National Stage of PCT/JP2005/000644	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANTS Nobuo NAITO et al.			
				FILING DATE May 23, 2006			
U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Name			
/HN/	1.	2003/0164243 A1	09/04/2003	ARAKAWA et al.			
/HN/	2.	2003/0007341 A1	01/09/2003	SHIMAMURA et al.			
/HN/	3.	2003/0094296 A1	05/22/2003	KOJIMA et al.			
FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation	
/HN/	4.	JP-A-2003-318596	11/07/2003	JAPAN	X	X	
/HN/	5.	JP-A-2003-258488	09/12/2003	JAPAN	X	X	
/HN/	6.	JP-A-2002-347166	12/04/2002	JAPAN	X	X	
/HN/	7.	JP-A-2003-037388	02/07/2003	JAPAN	X	X	
/HN/	8.	JP-A-2003-086991	03/20/2003	JAPAN	X	X	
/HN/	9.	JP-A-2000-013088	01/14/2000	JAPAN	X	X	
/HN/	10.	JP-A-2000-059079	02/25/2000	JAPAN	X	X	
/HN/	11.	JP-A-2002-009484	01/11/2002	JAPAN	X	X	
OTHER DOCUMENTS							
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)					
EXAMINER				/Hung Ngo/			
				DATE CONSIDERED 02/29/2008			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: May 23, 2006